| Electronic Acknowledgement Receipt   |  |  |  |  |
|--------------------------------------|--|--|--|--|
| EFS ID:                              | 1324581  |  |  |  |
| Application Number:                  | 10606512   |  |  |  |
| International Application Number:    |  |  |  |  |
| Confirmation Number:                 | 5217   |  |  |  |
| Title of Invention:                  | Method for cleaning a processing chamber and method for manufacturing a semiconductor device |  |  |  |
| First Named Inventor/Applicant Name: | Jung-Wook Kim  |  |  |  |
| Customer Number:                     | 22150  |  |  |  |
| Filer:                               | Frank Chau/Mel Rodriguez   |  |  |  |
| Filer Authorized By:                 | Frank Chau   |  |  |  |
| Attorney Docket Number:              | 8054-23 (AW8037US/JJ)  |  |  |  |
| Receipt Date:                        | 20-NOV-2006  |  |  |  |
| Filing Date:                         | 26-JUN-2003  |  |  |  |
| Time Stamp:                          | 16:06:14   |  |  |  |
| Application Type:                    | Utility  |  |  |  |

## Payment information:

| Submitted with Payment | no |
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## File Listing:

| Document<br>Number | Document Description                     | File Name       | File Size(Bytes) | Multi<br>Part /.zip | Pages<br>(if appl.) |
|--------------------|--|-----------------|------------------|---------------------|---------------------|
| 1                  | Amendment - After Non-Final<br>Rejection | 8054-23-amd.pdf | 859180           | no                  | 11                  |
| Warnings:          |  |                 |                  |                     |                     |

| Information:                 |        |
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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.